

Session No.	Session Title	Session Chair
	Opening Plenary Session	Dr. Hiroyuki Niino AIST, Japan
1	Modeling and Simulation	Prof. Tetsuya Makimura University of Tsukuba, Japan
2	Special Session 1-1	Prof. Dr.-Ing. Stephan Barcikowski Center for Nanointegration Duisburg-Essen (CENIDE), University of Duisburg-Essen, Germany
3	3-D micro- and nano-fabrication 1	Prof. Shoji Maruo Yokohama National University, Japan
4	Industrial applications/Manufacture of micro devices and systems	Dr. Yuji Sato JWRI, Osaka University, Japan
5	Burst ablation	Prof. Yasutaka Hanada Hirosaki University, Japan
6	Special Session 1-6	Prof. Dr.-Ing. Stephan Barcikowski Center for Nanointegration Duisburg-Essen (CENIDE), University of Duisburg-Essen, Germany
7	3-D micro- and nano-fabrication 2	Dr. Kotaro Obata RIKEN, Japan
8	Surface Processing 1	Prof. Mitsuhiro Terakawa Keio University, Japan
9	Fundamental Aspects	Prof. Gediminas Račiukaitis FTMC - Center for Physical Sciences and Technology, Lithuania
10	Special Session 1-2	Prof. Dr.-Ing. Stephan Barcikowski Center for Nanointegration Duisburg-Essen (CENIDE), University of Duisburg-Essen, Germany
11	Micro-machining	Prof. Yongfeng Lu University of Nebraska-Lincoln, USA
12	Surface processing 2	Dr. Godai Miyaji Tokyo University of Agriculture and Technology, Japan
13	Ultra-short pulse laser processing 1 (Beam shaping)	Dr. Yasuhiko Shimotsuma Kyoto University, Japan
14	Special Session 1-3	Prof. Dr.-Ing. Stephan Barcikowski Center for Nanointegration Duisburg-Essen (CENIDE), University of Duisburg-Essen, Germany
15	Micro-welding	Dr. Markus Kogel-Hollacher Precitec, Germany
16	Surface processing and related technologies	Dr. Daisuke Nakamura Kyushu University, Japan
17	Ultra-short pulse laser processing 2 (Surface of transparent materials)	Dr. Hiroaki Nishiyama Yamagata University, Japan
18	Laser-based direct-write techniques 1	Dr. Yoshiki Nakata ILE, Osaka University, Japan
19	Cutting and other processing technologies	Prof. Keiji Yamada Hiroshima University, Japan
20	Micropatterning structuring and modification	Prof. Dr. Thomas Lippert Paul Scherrer Institute, Switzerland
21	Ultra-short pulse laser processing 3 (Drilling, Cutting)	Dr. Mizue Mizoshiri Nagaoka University of Technology, Japan

Session No.	Session Title	Session Chair
22	Special Session 1-4	Prof. Dr.-Ing. Stephan Barcikowski Center for Nanointegration Duisburg-Essen (CENIDE), University of Duisburg-Essen, Germany
23	Glass/Ceramic processing	Prof. Duncan P. Hand Heriot-Watt University, UK
24	LIPSS, micro-patterning and structuring 1	Prof. Peter R. Herman University of Toronto, Canada
25	Ultra-short pulse laser processing 4 (3D glass modification and microfluidic chip)	Dr. Calum Ross Heriot-Watt University, UK
26	Special Session 1-5	Prof. Dr.-Ing. Stephan Barcikowski Center for Nanointegration Duisburg-Essen (CENIDE), University of Duisburg-Essen, Germany
27	Special Session 2-1	Prof. Kenichi Ishikawa The University of Tokyo, Japan
28	LIPSS, micro-patterning and structuring 2	Prof. Shigeki Matsuo Shibaura Institute of Technology, Japan
29	Ultra-short pulse laser processing 5 (3D Micro/Nano fabrication of transparent materials)	Prof. Takuro Tomita , Tokushima University, Japan Prof. Ya Cheng , Shanghai Institute of Optics and Fine Mechanics, CAS, China
30	Laser-based direct-write techniques 2	Prof. Yasutaka Hanada Hirosaki University, Japan
31	Special Session 2-2	Prof. Kenichi Ishikawa The University of Tokyo, Japan
32	LIPSS, micro-patterning and structuring 3	Dr. Mizue Mizoshiri Nagaoka University of Technology, Japan
33	Ultra-short pulse laser processing 6 (Metal)	Dr. Masahito Katto University of Miyazaki, Japan
34	Lasers, optics and systems for laser microprocessing	Prof. Yoshio Hayasaki Utsunomiya University, Japan
35	Special Session 2-3	Prof. Kenichi Ishikawa The University of Tokyo, Japan
36	Process monitoring and control 1	Dr. Masayuki Kakehata AIST, Japan
37	Ultra-short pulse laser processing 7 (New trend)	Dr. Razvan Stoian Laboratoire Hubert Curien CNRS-UJM, France
38	Lasers, optics and systems for laser microprocessing 2	Dr. Yasuhiro Okamoto Okayama University, Japan
39	Special Session 2-4	Prof. Kenichi Ishikawa The University of Tokyo, Japan
40	Process monitoring and control 2	Dr. Daisuke Nakamura Kyushu University, Japan
	Short presentations for Poster Session 1	Dr. Yasuhiro Okamoto Okayama University, Japan
	Short presentations for Poster Session 2	Prof. Mitsuhiro Terakawa Keio University, Japan
	Closing Plenary Session	Dr. Hiroyuki Niino AIST, Japan